



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

: Confirmation No. 5731

Akihisa HONGO et al.

: Attorney Docket No. 2001_0133A

Serial No. 09/762,582

: Group Art Unit 1753

Filed April 12, 2001

: Examiner Arun Phasge

SUBSTRATE PLATING
METHOD AND APPARATUS

Mail Stop: Amendment

PETITION FOR EXTENSION OF TIME

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Petition hereby is made for a two month extension of time to respond to the communication of

June 10, 2005.

The fee of \$450.00 is

submitted herewith.
 to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.
 Small entity status of this application is established by a Small Entity Status Assertion which
 is enclosed.
 has been previously submitted.

Respectfully submitted,

Akihisa HONGO et al.

By

David M. Ovedovitz
David M. Ovedovitz
Registration No. 45,336
Attorney for Applicants

DMO/jmj
Washington, D.C. 20006-1021
Telephone (202) 721-8200
Facsimile (202) 721-8250
November 10, 2005

11/14/2005 SZEWDIE1 00000035 09762582

01 FC:1252

450.00 0P